

	2000. 7.	IP CONTROLLER	
	2000. 8.	ION GAUGE	
	2000. 12.	DIPC2000	
	2000. 12.	240L ION PUMP	
	2001. 2.	ION Gauge	
	2001. 5.	ION PUMP	
	2001. 8.	ION PUMP	
	2001. 11.	E-Beam Evapovator Vacuum system	
	2001. 12.	ION PUMP 120L/S	
	2002. 2.	Flanged Elbow	
	2002. 7.	ION PUMP 240L/S	
	2002. 8.	VACUUM PUMP	
	2002. 10.	CF Flange 8"	
	2002. 12.	CHAMBER	
	2002. 12.	IC Feedthru	
	2003. 2.	ION GAUGE	
	2003. 3.	NEG STRIP	
	2003. 3.	SPUTTER(Processing chamber)	
	2003. 6.	Vacuum Bellows	
	2003. 9.	8inch Spool	
	2003.11.	Vacuum Bellows	
가	2000. 2.	Zero Length Flange	
	2000. 4.	ION PUMP with Baking Unit	
	2000. 6.	IP LEMO CONNECTORS	
	2000. 11.	ION PUMP CONTROLLER	
	2000. 12.	ION PUMP	
	2001. 2.	ION PUMP CONTROLLER	
	2001. 3.	ION PUMP 240L	
	2001. 4.	DIPC-2000 10set	
	2001. 7.	TDS Frame	
	2001. 8.	ION PUMP CONTROLLER	
	2001. 10.	ION PUMP 360L/S	
	2001. 12.	ION PUMP 360L/S	
	2002. 1.	ION PUMP CONTROLLER	
	2002. 2.	ION PUMP	
	2002. 7.	Vxwork OEM License	
	2002. 8.	ION PUMP 480L/S	
	2002. 8.	NEG PUMP	
	2002. 9.	ION PUMP CONTROLLER DIPC2000	
	2002. 10.	ION PUMP 240L/S D-Type	
	2002. 11.	PUMP STATION	
	2002. 12.	ION PUMP 60L/S	
	2003. 3.	ION PUMP CONTROLLER	
	2003. 6.	Load-Lock Chamber	
	2003. 8.	ION PUMP CONTROLLER	
	2003. 8.	CONTROLLER VIPC4200	
	2003. 11.	ION PUMP 240L/S	
	2003. 12.	ION PUMP	

	2000. 1.	(600l/s,360l/s)	
	2000. 2.	network	
	2000. 4.	Base module	
	2000. 6.		
	2000. 9.	Compact PLC	
	2001. 1.	EMAT	
	2001. 3.	Profibus Network	
	2001. 6.	Heating Chamber asseuby	
	2001. 8.		
	2001. 11.	Signal Transmitter	
	2001. 12.	ION PUMP	
	2002. 4.	Replacement Cathode	
	2002. 5.	RotaryMotion Feedthrough	
	2002. 9.	Compact PLC	
	2002. 9.		
	2002. 12.		
	2003. 2.		
	2003. 2.	Compact PLC	
	2003. 12.	Welded Bellows	
	2000. 1.	ION PUMP REPAIR	
	2000. 6.	ION PUMP REPAIR	
	2000. 12.	ION PUMP 240L/S	
	2001. 5.	ION PUMP VIP240L/S	
	2001. 7.	Pumping Speed system	
	2001. 7.	TPD Vacuum Chamber	
	2001. 10.	XHV Test Chamber	
	2002. 3. 28	ION PUMP 600L/S	
	2002. 5. 29	ION PUMP 240L/S	
	2002. 7. 31	TML&CVCM Chamber system	
	2002. 10. 15.	Crxopump Pumping Speed System	
	2003. 11.	XHV Vacuum Chamber 1EA	
	2000. 5.	Digital Input Module	
	2000. 8.	PC104 I/O Module	
	2001. 10.	D/I Module	
	2003. 2.	I/O UNIT	
	2003. 6.	I/O UNIT 1LOT	
	2003. 10.		
	2003. 11.	Monitoring software	
	2003. 12.	S/W	
	2000. 8.	Controller	
	2001. 11.	ION PUMP SYSTEM	
	2001. 12.	ION PUMP 120L/S	
	2003. 6.	Vacuum Bellows	
	2003. 6.	Roughing Bellows	
	2001. 9.	Six voay Chamber	
	2002. 5. 29	ION PUMP 120L/S	
	2003. 7.		
	2003. 12.	ION PUMP	
LG	2002. 12	MGT Cathode	
MGT	2003. 6	Sample Cathode	
	2000. 4.	ION PUMP 360L/S	
	2002. 5.	ION PUMP	
	2002. 5	CONTROLLER DIPC-2000	
	2002. 6.		